PATENT APPLICATION

Docket Number: 071469-0303535

∕⊗lient Reference: RAJ-001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of

DAVID L O'MEARA, et al.

Group Art Unit: 2812

Application No.: 10/630,969

Examiner: Renee Berry

Filed: July 31, 2003

Confirmation No.: 1846

For: FORMATION OF ULTRA-THIN OXIDE LAYERS BY SELF-LIMITING INTERFACIAL

OXIDATION

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. As this application was filed after June 30, 2003, no copies of the cited U.S. patents/ patent applications are enclosed. However, one copy of each of the non-patent references are enclosed. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicants with the next Office communication to indicate that the references have been considered, per MPEP § 609.

This Information Disclosure Statement is being filed after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

I hereby certify that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. 37 CFR 1.97(e)(1).

These references were cited in a Partial International Search Report, dated March 29, 2005, in a corresponding foreign application.

Respectfully Submitted,

Jeffrey D. Karceski

Registration Number 35914 Customer Number: 00909

Date: April 22, 2005

PILLSBURY WINTHROP LLP Telephone: (703) 905-2000 Facsimile: (703) 905-2500

P.O. Box 10500 McLean, VA 22102

PTO/SB/08a (08-03)
Approved for use through 07/31/2006. OMB 0651-0031
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Substitute for form 1449A/PTO				Complete if Known			
				Application Number	10/630,969		
11	NFORMATION DISC	CLC	SURE	Filing Date	07/31/2003		
STATEMENT BY APPLICANT				First Named Inventor	DAVID L O'MEARA		
				Art Unit	2812		
	(Use as many sheets as nec	essarv)	Examiner Name	Renee Berry		
Sheet		of	1	Attorney Docket Number	071469-0303535		

FEBT & TRACE

			U. S. PATENT	DOCUMENTS	
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ^{2 (if known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	1	^{US-} 6,258,731 B1	07-10-2001	ANDO	
	2	^{US-} 2001/0102859 A1	08-01-2002	Y00	
	3	^{US-} 5,296,412	03-22-1994	OHSAWA	
	4	^{US-} 2002/111001 A1	08-15-2002	AHN et al.	
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FOREIGN PATENT DOCUMENTS									
Examiner Initials*	Cite No. ¹	Foreign Patent Document Country Code ³ -Number ⁴ -Kind Code ⁵ (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	τ [¢]			
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This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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Substitute for	form 1449B/PTO			Complete if Known		
				Application Number	10/630,969	
	RMATION DIS			Filing Date	07/31/2003	
STATI	EMENT BY A	APPLI	ICANT	First Named Inventor	DAVID L O'MEARA	
				Art Unit	2812	
	(Use as many sheets as	necessary,	9	Examiner Name	Renee Berry	
Sheet	1	of	1	Attorney Docket Number	071469-0303535	

	NON PATENT LITERATURE DOCUMENTS							
Examiner Initials* Cite No. Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (boo magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.								
	I	J. DERRIEN, "SiO2 Ultra Thin Film Growth Kinetics as Investigated by Surface Techniques," Surface Science, North-Holland Publishing Company, pp. 32-46, (June 1982).						
	II	C. RAISIN ET AL., "Work Function Measurements During Growth of Ultra Thin Films of SiO2 on Characterized Silicon Surfaces," Solid-State Electronics, Pergamon Press Ltd., Vol. 27 (No. 5), pp. 413-417, (May 1984).						
	III	MAHISHA KUNDU ET AL., "Effect of oxygen pressure on the structure and thermal stability of ultrathin Al2O3 films on Si (001)," Journal of Applied Physics, American Institute of Physics, Vol. 91 (No. 1), pp. 492-500, (January 1, 2002).						
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